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Application No.	Applicant(s)	
10/647,230	TAKEMURA ET AL.	
Examiner	Art Unit	
Dung V Nguyen	3723	

SEARCHED				
Class	Subclass	Date	Examiner	
451	540	5/3/2004	DVN	
451	541	5/3/2004	DVN	
451	546	5/3/2004	DVN	
451	547	5/3/2004	DVN	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
			

	DATE	EXMR
See Search History	5/4/2004	DVN
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